



COPY OF PAPERS
ORIGINALLY FILED

PATENT

10/032,930 TRADEMARK CENTER
Response to Restriction Requirement mailed June 6, 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Heikyung Min et al.

Appn. No.: 10/032,930

Filed: October 29, 2001

For: APPARATUS AND METHOD FOR
REDUCING SURFACE ZENER DRIFT
USING Ti-BASED METALLURGY

Group Art Unit: 2818

Examiner: Dung Anh Le

RESPONSE TO RESTRICTION
REQUIREMENT MAILED JUNE 6, 2002

4/ Electron
G. Story
7-17-02
TECHNOLOGY CENTER 2800
JUL -2 2002
RECEIVED

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The Examiner required that the above-identified application be restricted to claims 1-15 which are drawn to semiconductor device, or claims 16-20 which are drawn to a process of making a semiconductor device. As a result, applicants elect to prosecute claims 1-15 without traverse.

Dated: 6-20-02

By:

Respectfully submitted,

Mark C. Pickering
Mark C. Pickering
Registration No. 36,239

Attorney for Assignee

30 Fifth Street, Suite 200
P.O. Box 300
Petaluma, CA 94953-0300
Direct Dial Telephone No. (707) 762-5583
Main Telephone: (707) 762-5500
Facsimile: (707) 762-1200

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service, postage prepaid, in an envelope, addressed to Box _____, Commissioner for Patents, Washington D.C. 20231-9999 on 06-21-02.

Dated: 06-21-02 By Karen L. Rugg

Atty. Docket No. 100-16800 (P05108)